



AF/3742  
PATENT  
Attorney Docket No.: ASX-015CP/JFW  
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Chen et al.  
SERIAL NO.: 09/774,165 GROUP NO.: 3742  
FILING DATE: January 26, 2001 EXAMINER: Paschall, Mark H.  
TITLE: Integrated Plasma Chamber and Inductively-Coupled Toroidal Plasma Source

Commissioner for Patents  
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**RESPONSE**

This is in response to Office action, Paper No. 10, mailed from the Patent Office on July 14, 2003, in the above-identified patent application. In the event any fees are due, the Commissioner is hereby authorized to charge any such fees to Attorney's Deposit Account No. 50-3081.

Applicants respectfully request reconsideration and entry of this Response, in which:

- Remarks begin on page 2.